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J1046 U.S. PTO
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Mailed on July 9, 2001

J1046 U.S. PTO
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07/09/01

Commissioner of Patents and Trademarks

Washington, D.C. 20231

Sir:

Please file the following enclosed patent application papers:

This application is a continuation-in-part of U. S. Patent Application no. 09/343,057, which is a continuation-in-part of U. S. Patent Application no. 08/919,382, now U. S. Patent no. 5,952,668, which is a continuation-in-part of U. S. Patent Application no. 08/581,185, now U. S. Patent no. 5,777,342, which is a continuation-in-part of U. S. Patent Application no. 08/275,967, now U. S. Patent no. 5,866,911. I hereby claim all appropriate priority benefits with respect to these earlier applications.

Applicant: Stephen C. Baer

Title: SUPERRESOLUTION IN MICROLITHOGRAPHY AND
FLUORESCENCE MICROSCOPY

Specification, Claims, and Abstract: 36 Sheets.

Declaration: Date Signed: July 9, 2001


Drawings: (Formal) 16 Sheets.

Small Entity Declaration of Inventor.

Check for \$355.00 for Filing fee

Return Receipt Postcard Addressed to Applicant.

Very respectfully,


Stephen C. Baer, Applicant
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Express Mail Label #ET014639884US. Date of Deposit: July 9, 2001

I hereby certify that this correspondence is being deposited with the United States Postal Service using "Express Mail Post Office To Addressee" service under 37 CFR 1.10 on Deposit: July 9, 2001 and is addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231.

Signed: 
Stephen C. Baer
